Docket No.: 60188-419

office petition.

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :

Customer Number: 20277

Shigeo IRIE : Confirmation Number: 9324

Serial No.: 09/891,192 : Group Art Unit: 1756

Allowed: January 22, 2004

Filed: June 26, 2001 : Examiner: S.R. Mohamedulla

For: PATTERN FORMING METHOD AND APPARATUS FOR FABRICATING SEMICONDUCTOR DEVICE

PETITION UNDER 37 C.F.R. 1.313(c)(2) FOR WITHDRAWAL FROM ISSUE FOR CONSIDERATION OF AN INFORMATION DISCLOSURE STATEMENT UNDER §1.97 IN VIEW OF A REQUEST FOR CONTINUED EXAMINATION (RCE)

Mail Stop 313(c) Hon. Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This is a Petition under 37 C.F.R. 1.313(c)(2) for the withdrawal of this application from issue.

PETITION

1. Applicants hereby petition for the withdrawal of this application from issue.

PATENT ISSUE FEE

2. The issue fee for this case was paid on March 16, 2004.

04/07/2004 MGEBREM1 00000112 500417 09891192

01 FC:1460 130.00 DA

Serial No.: 09/891,192

REASON FOR WITHDRAWAL REQUEST

3. The reason for withdrawal from issue of this application is for consideration of an Information Disclosure Statement (IDS). Applicants are concurrently filing a Request for Continued Examination (RCE), pursuant to 37 C.F.R. §1.313(c)(2) and 37 C.F.R. §1.114 along with the IDS citing the reference to be considered.

PETITION FEES

4. The Commissioner is authorized to charge the \$130.00 fee for the present Petition to Deposit Account No. 50-0417.

The Commissioner is hereby authorized to charge any fees due or credit any overpayment in connection with the filing of this paper to Deposit Account 50-0417.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

Michael E. Eggarty

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Date: April 6, 2004